MAR 0.3 TON THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: TESHIROGI, Kazuo et al.

Serial No.: 10/708,067 (Div. Of S.N. 10/101,169)

Filed: February 6, 2004

For: SEMICONDUCTOR SUBSTRATE JIG AND METHOD FOR

MANUFACTURING A SEMICONDUCTOR DEVICE

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

March 3, 2004

Sir:

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The attention of the Patent and Trademark Office is hereby directed to the document listed on the attached Form PTO-1449. A copy of the document is attached. This document was made of record in parent application Serial No. 10/101,169.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449 and reference (1)

INFORMATION DISCLOSURE CITATION -PTO-1449

Atty. Docket No. 020334A

Serial No. 10/708,067

Applicant(s): TESHIROGI, Kazuo et al.

Filing Date: February 6, 2004

Group Art Unit:

## U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
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## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
	AF	11-307488	11/05/99	Japan	Abstract only
<b></b>	AG				
	AH				
<b></b> `	AI				
	AJ				

## OTHER DOCUMENTS

	AK	
	AL	
Examiner		Date Considered